



Corres. and Mail  
**BOX AF**

AF/2133  
2100

RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
GROUP ART UNIT 2100

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

COPY of # 9/B

Hiroshi SONOBE

Group Art Unit: 2133

Serial No.: 09/557,088

Examiner: Matthew C. Dooley

Filed: April 21, 2000

For: SEMICONDUCTOR INSPECTION METHOD

AMENDMENT UNDER 37 CFR §1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

RECEIVED

DEC 24 2003

Technology Center 2100

Sir:

In response to the Office Action mailed September 23, 2003,  
please amend the above-identified application as follows: